

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 1753
)	
Takeshi Nogami et al.)	Confirmation No.: 3159
)	
Application No. 10/775,935)	
)	
Filed: February 10, 2004)	
)	
For: SEMICONDUCTOR MANUFACTURING)	Examiner: Luan V. Van
APPARATUS AND METHOD FOR)	
MANUFACTURING SEMICONDUCTOR)	
DEVICES)	

MAIL STOP AFTER FINAL
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO DECEMBER 20, 2006 FINAL OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Final Office Action mailed December 20, 2006. Applicants respectfully request reconsideration of the application in view of this amendment and remarks herein.